PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Nassiopoulou et al. )
Serial No.: 10/502,465
Confirmation: 3973
Filed: July 23, 2004 )
Title: Low Power Silicon Thermal Sensors and Microfluidic Devices Based on the Use of Porous Sealed Air Cavity Technology or Microchannel Technology
Group Art Unit: 2884
Examiner: Rosenberger, Frederick F.
Attorney Docket No.: 30848/40323
Customer No.: 04743

## AMENDMENT "C"

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

In response to the final official action dated October 18, 2006, please amend the above-identified patent application as set forth herein.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.